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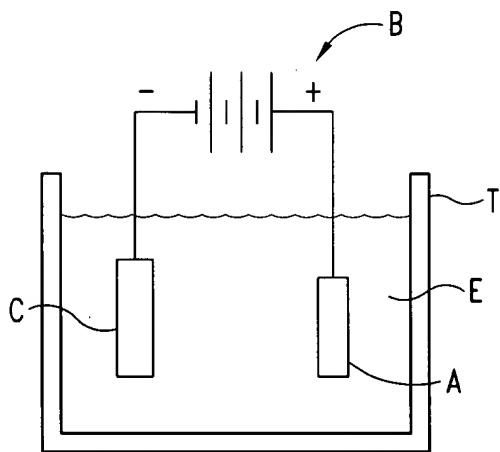


Fig. 1
(Prior Art)

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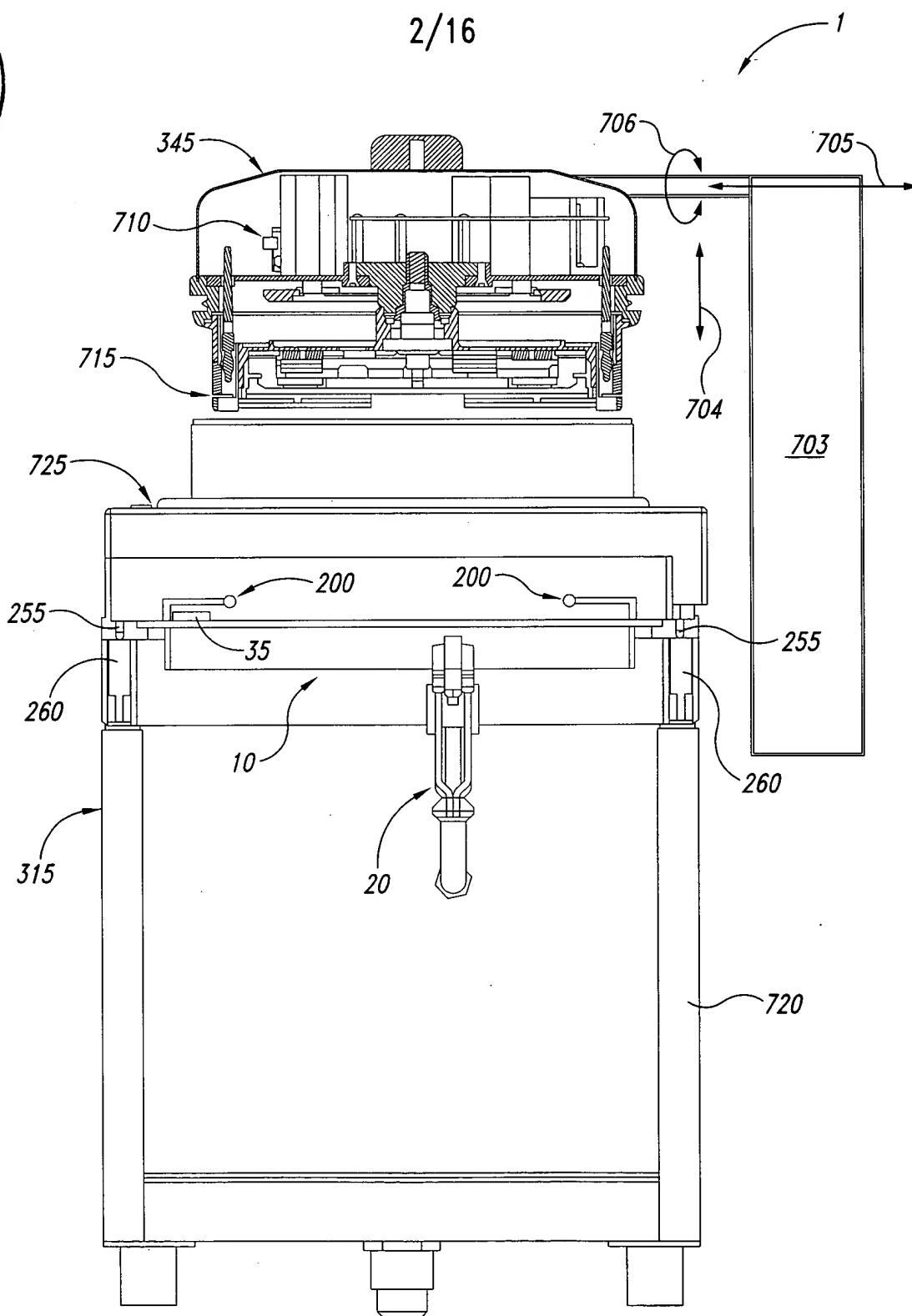


Fig. 2

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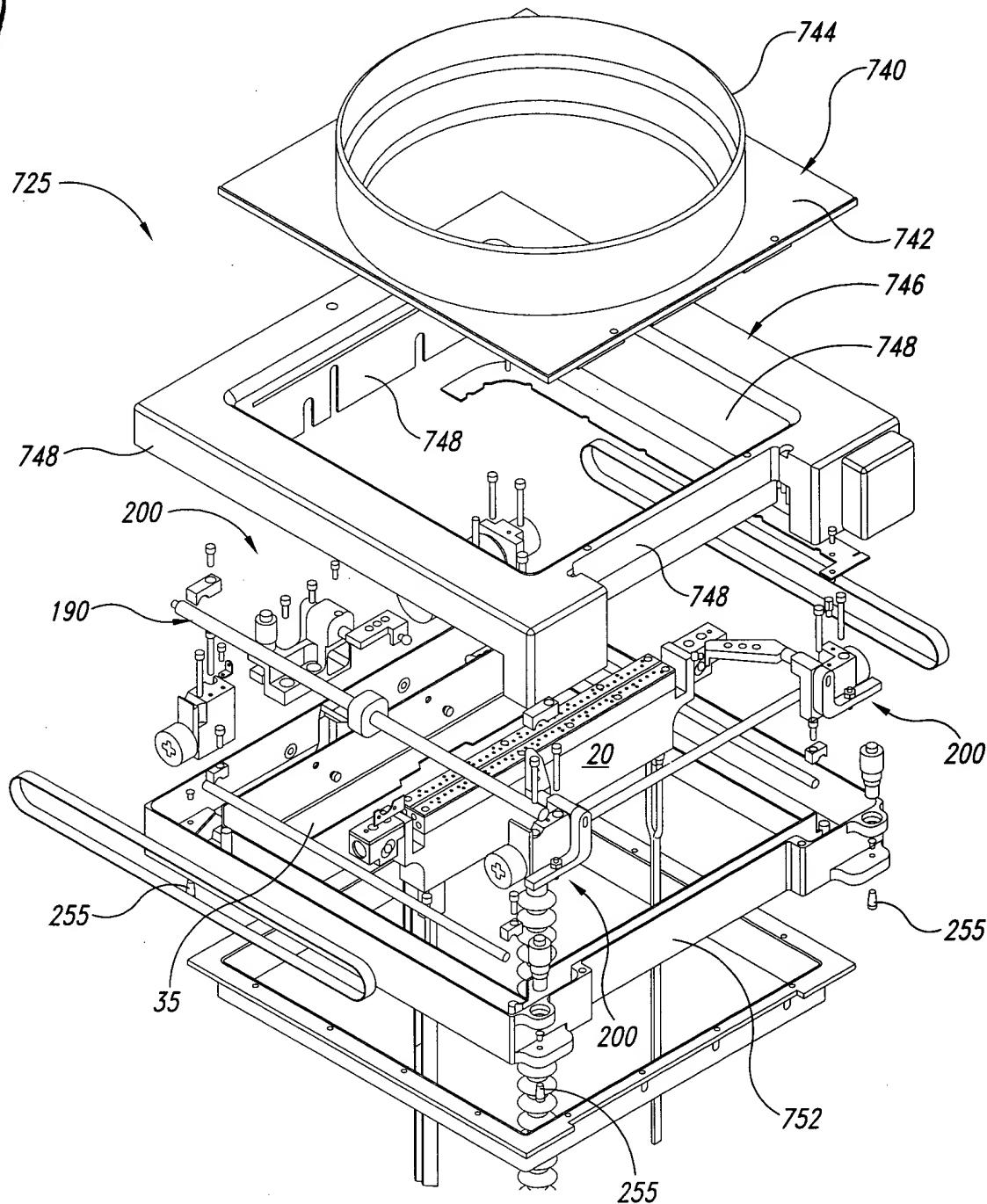


Fig. 3A

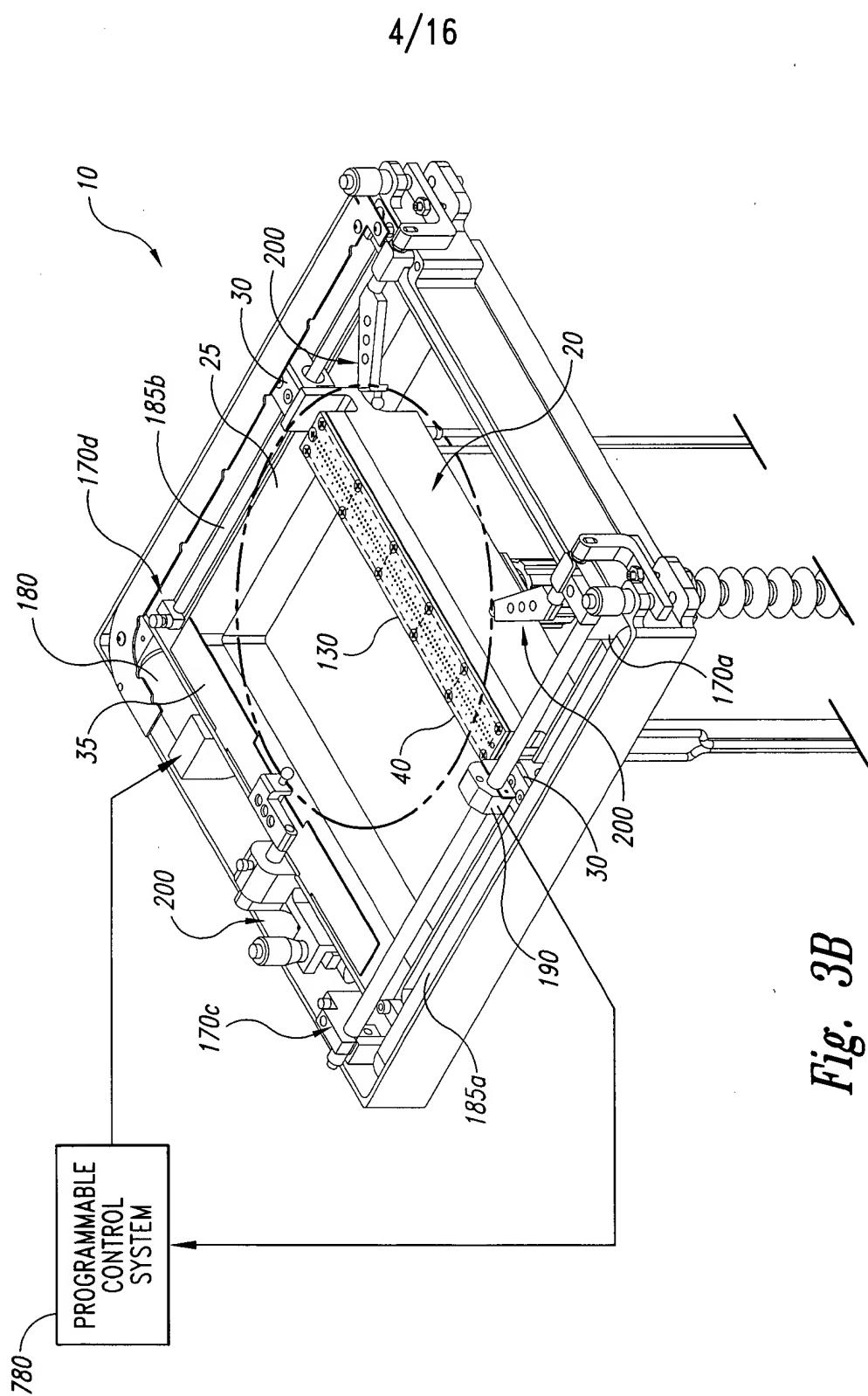


Fig. 3B

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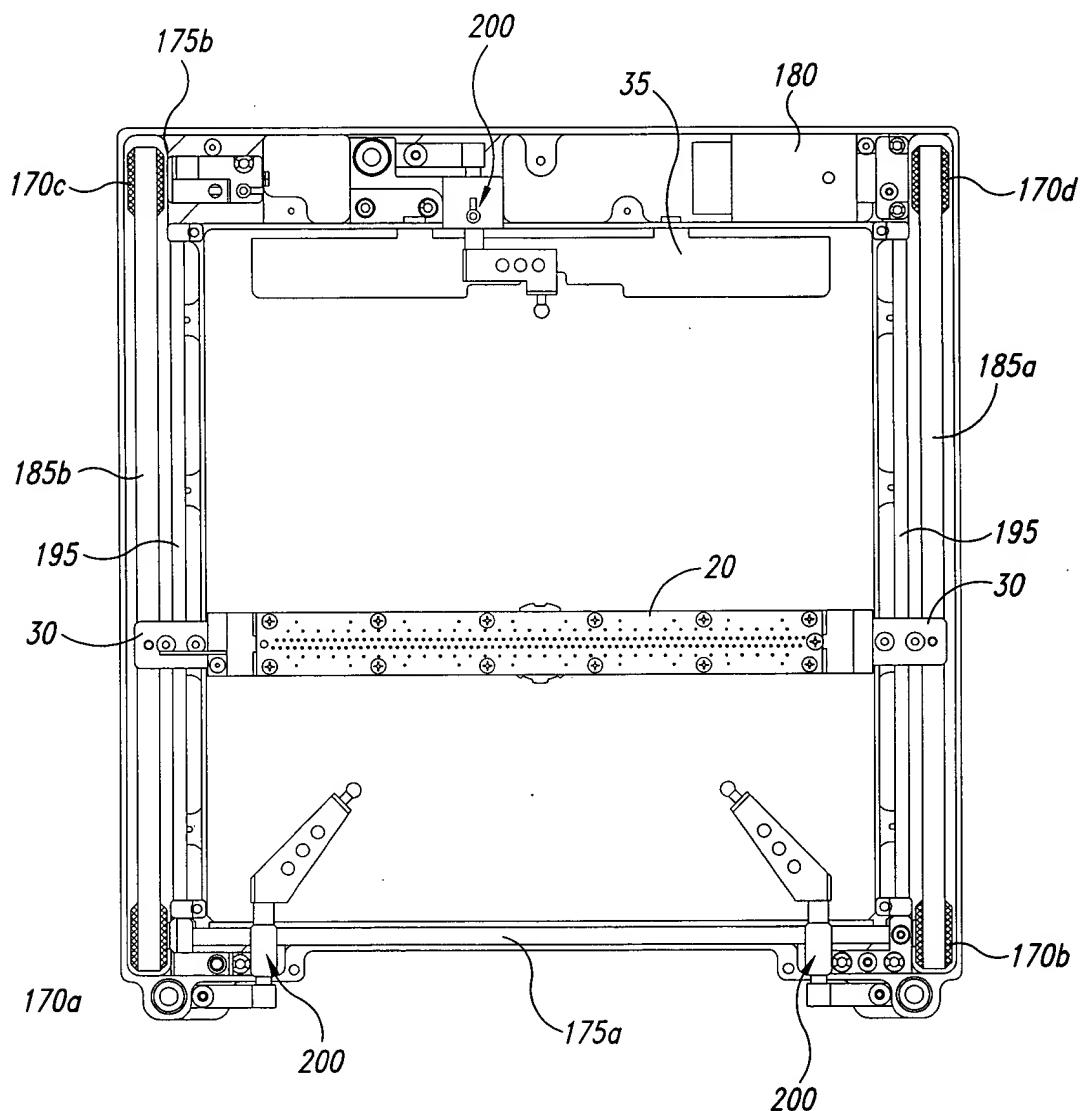


Fig. 3C

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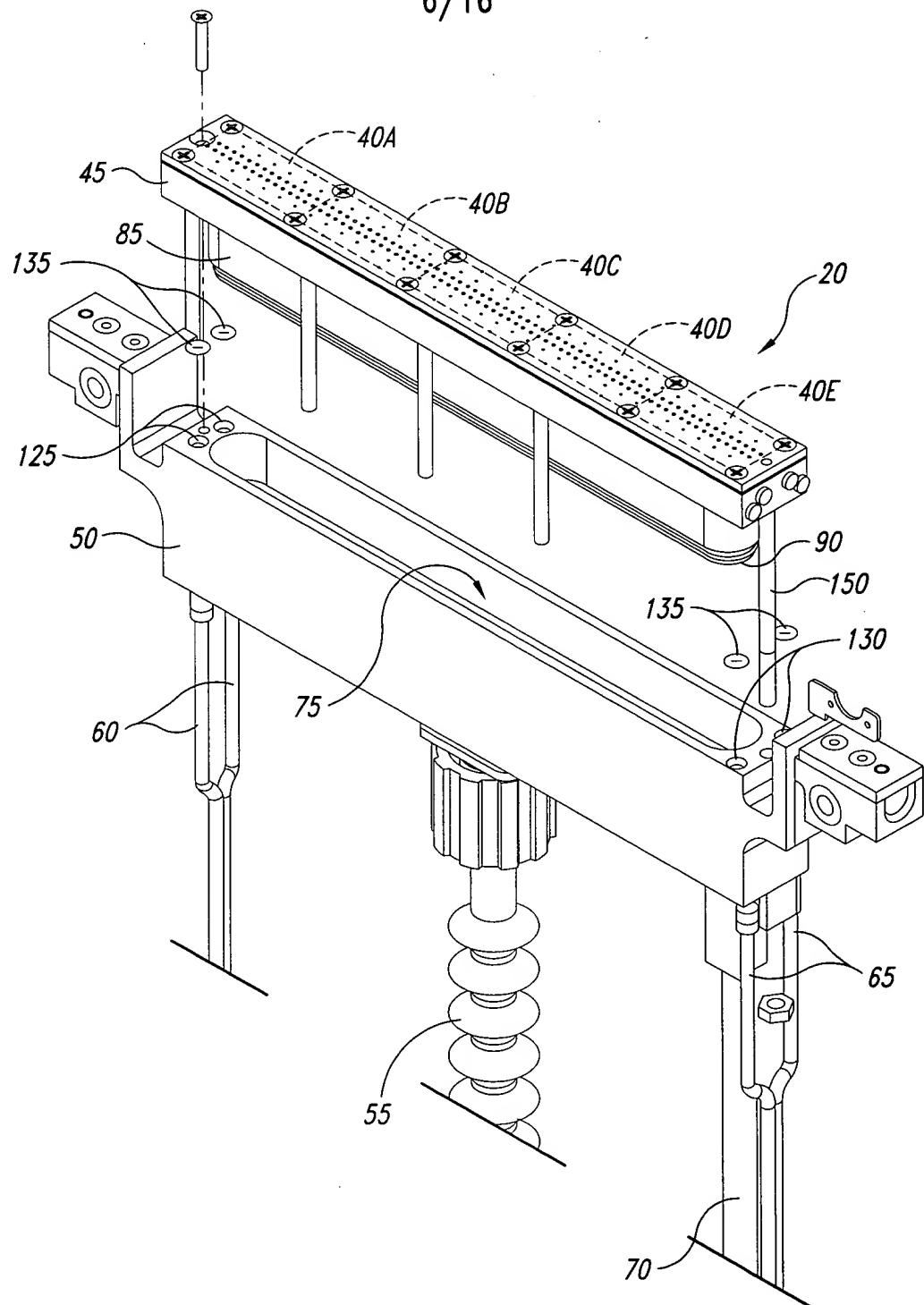
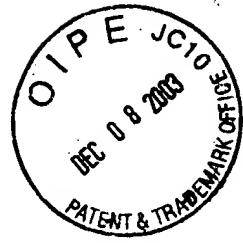


Fig. 4A



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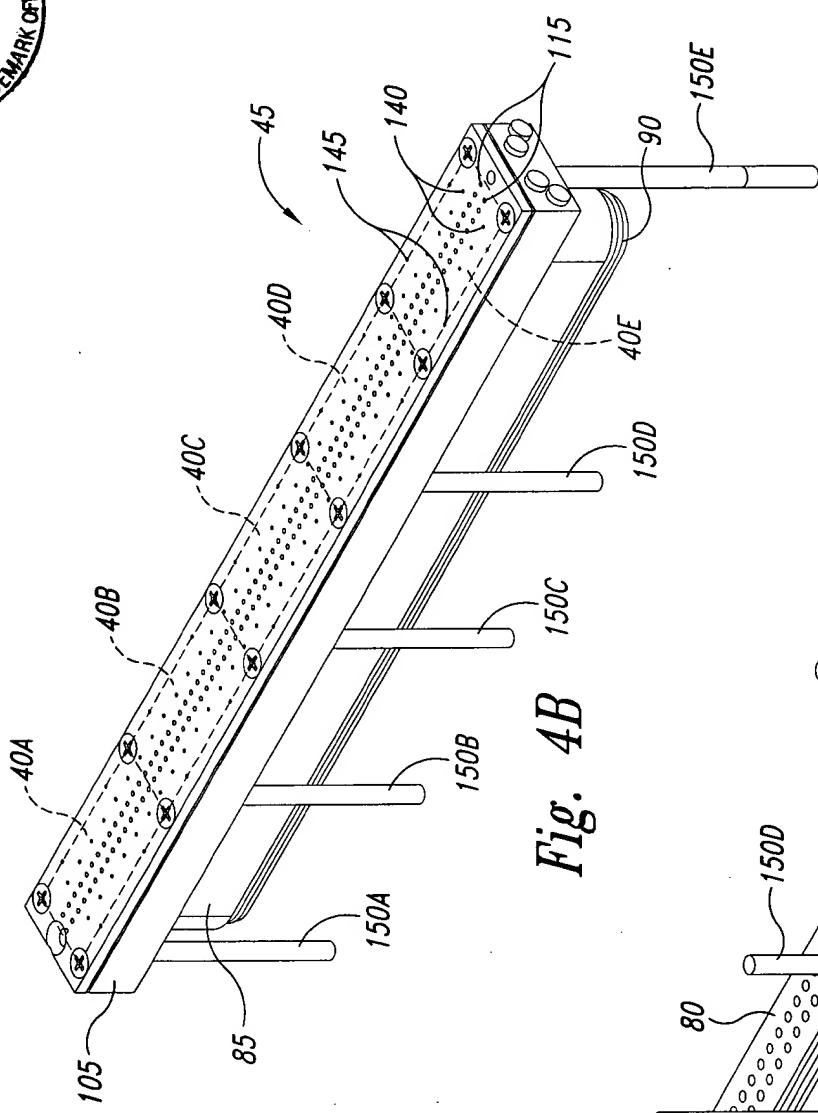


Fig. 4B

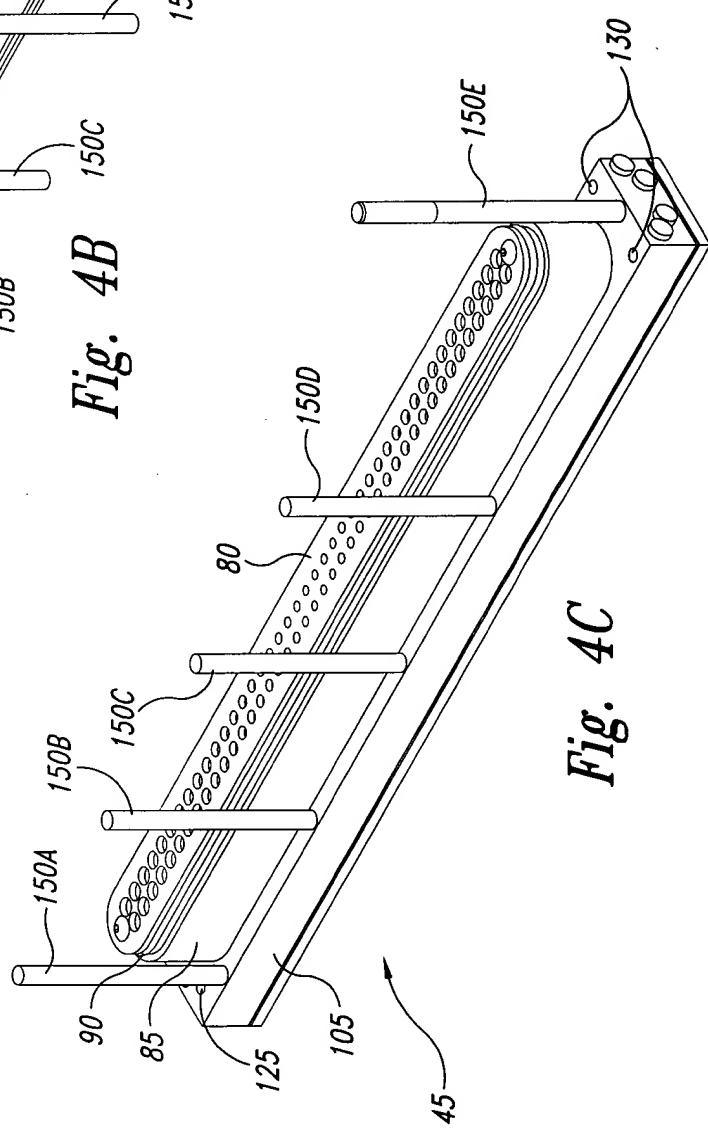


Fig. 4C

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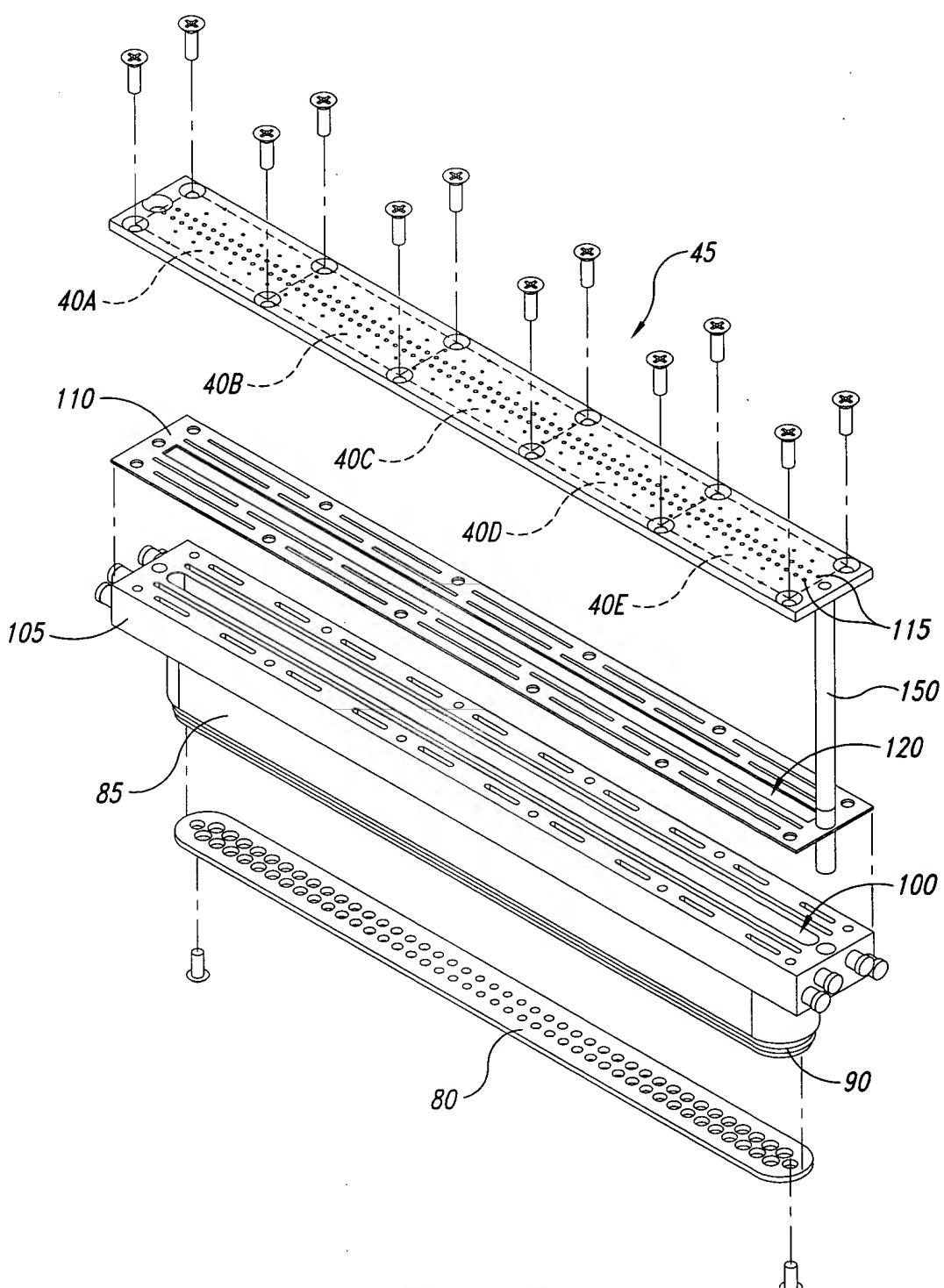


Fig. 4D

Atty Docket: 29195-8115US

Application No.: 09/782,216

Inventors: D. Woodruff et al.

Title: PROCESSING APPARATUS INCLUDING A REACTOR FOR ELECTROCHEMICALLY ETCHING A MICROELECTRONIC WORKPIECE
REPLACEMENT SHEET

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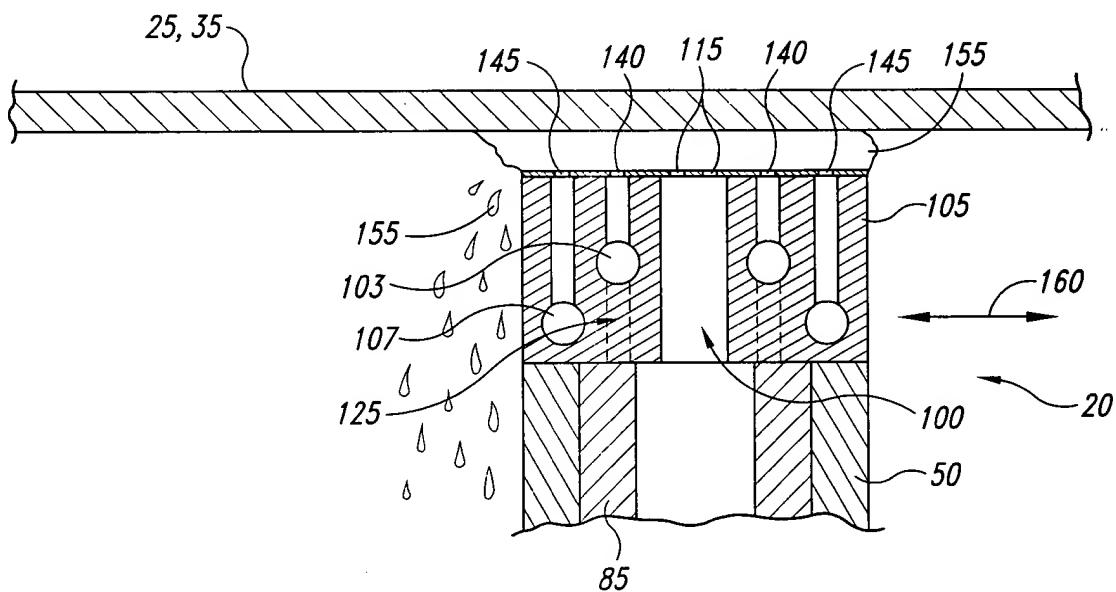
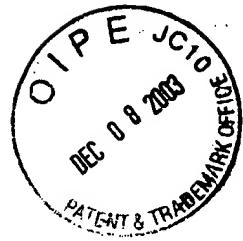


Fig. 5

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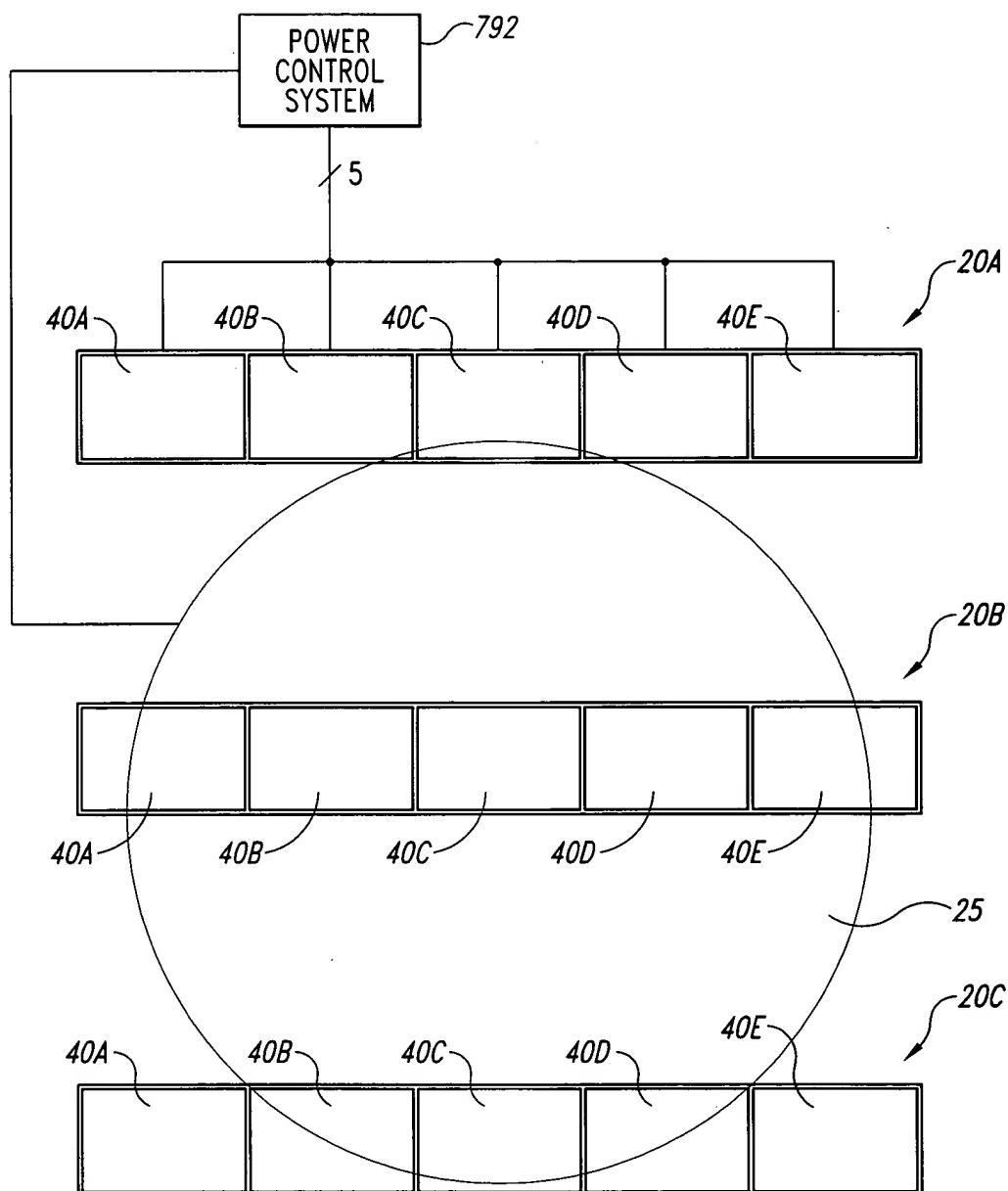
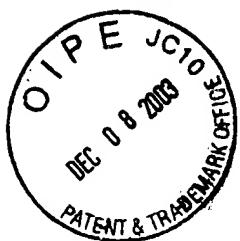


Fig. 6



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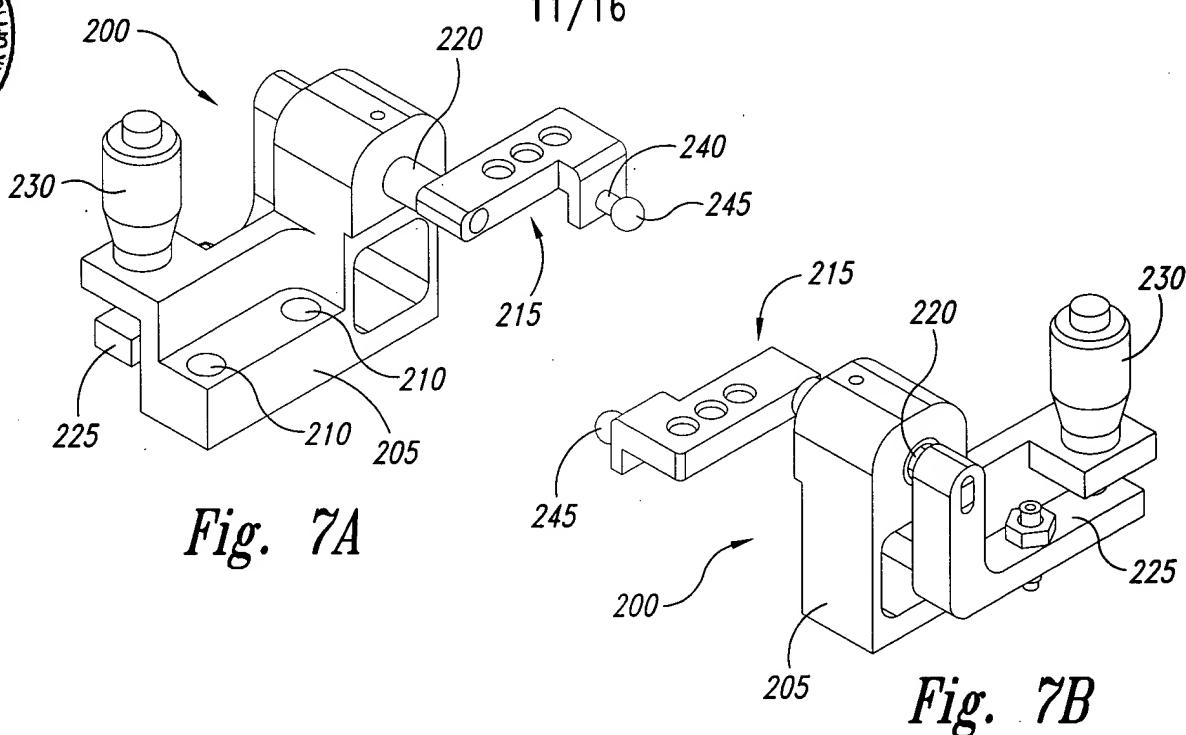


Fig. 7A

Fig. 7B

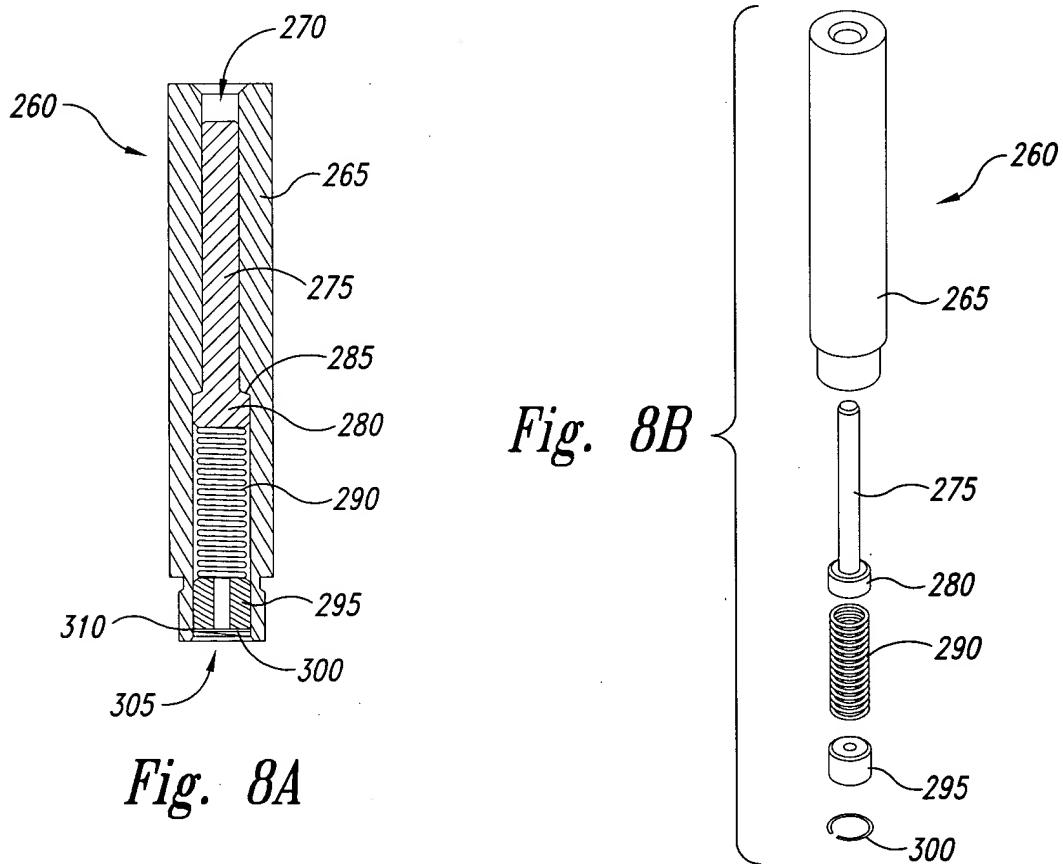


Fig. 8A

Fig. 8B

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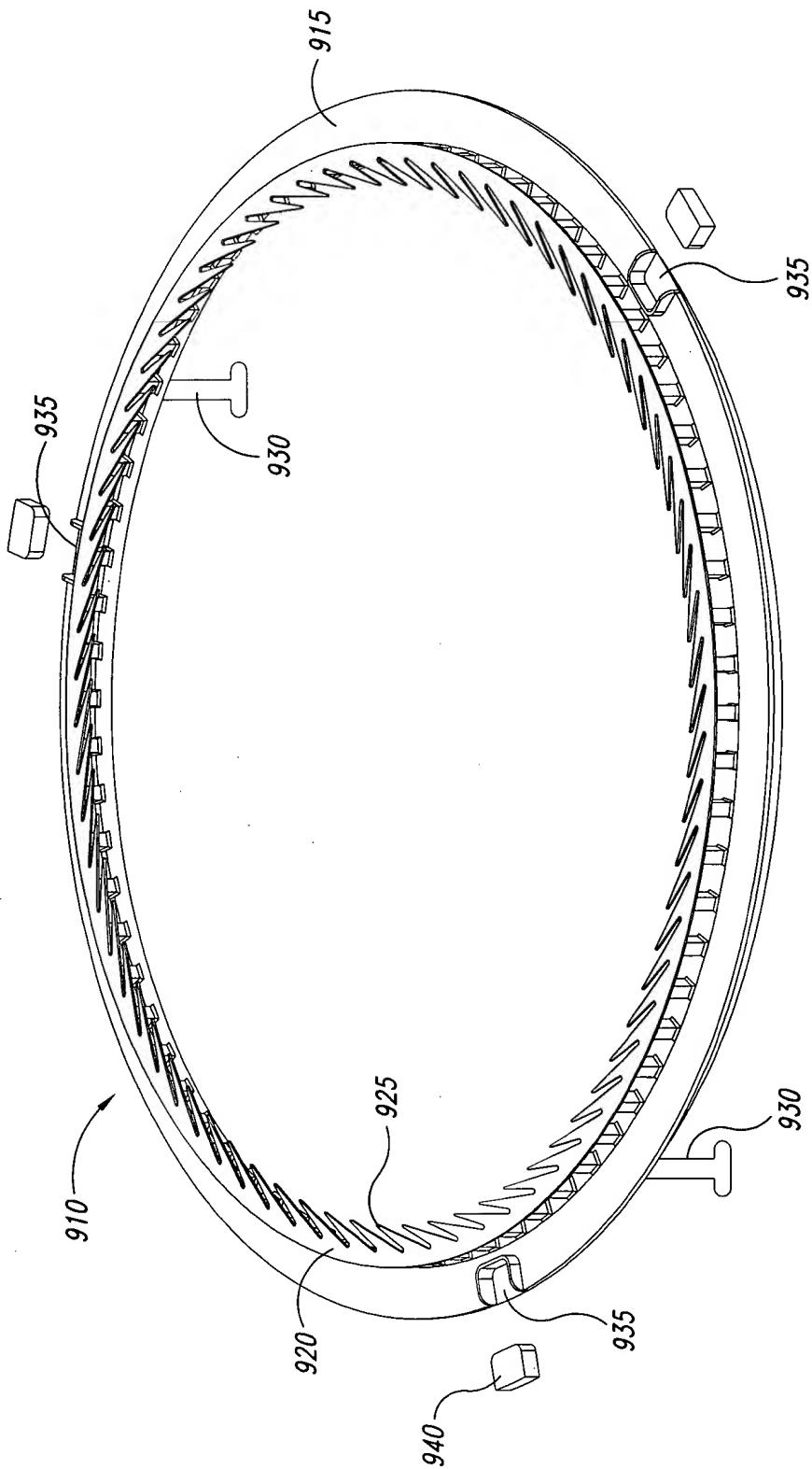
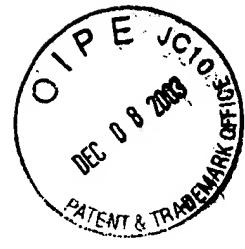


Fig. 9

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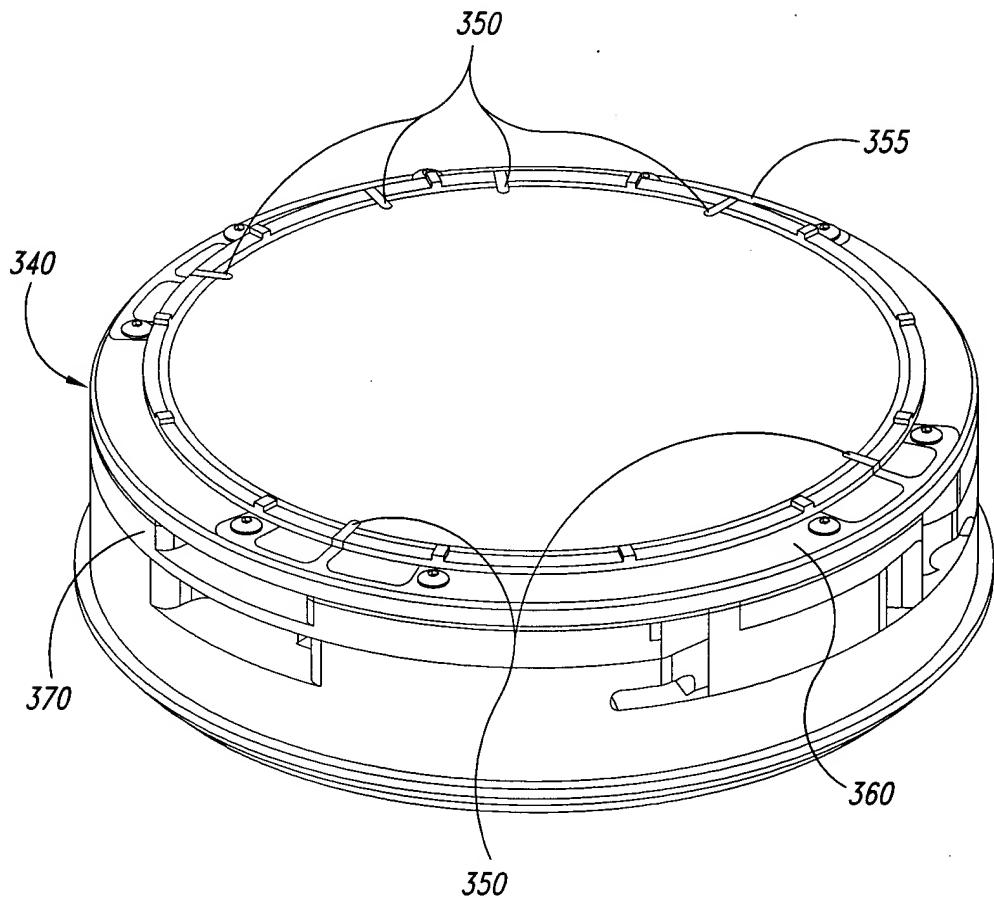


Fig. 10

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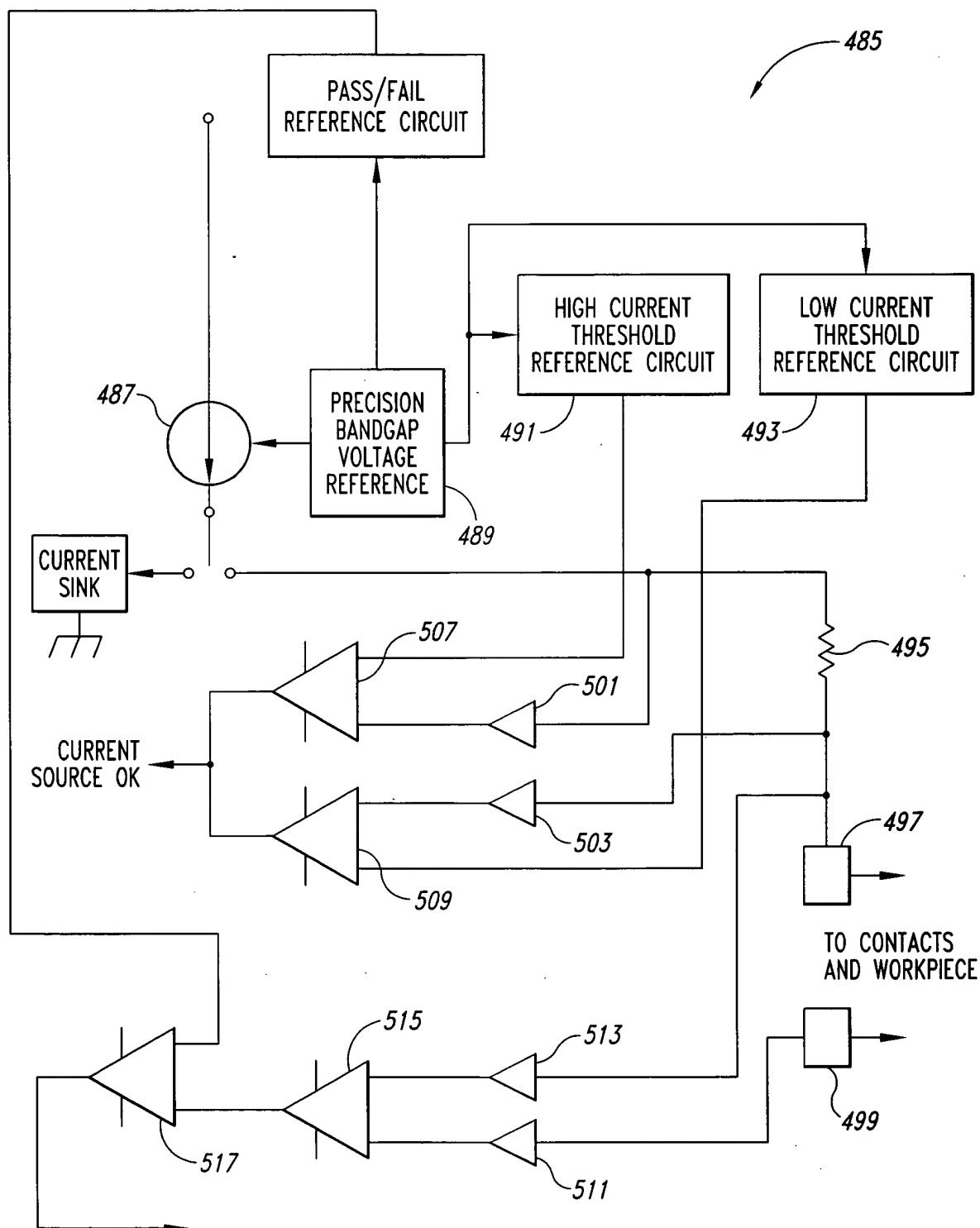


Fig. 11

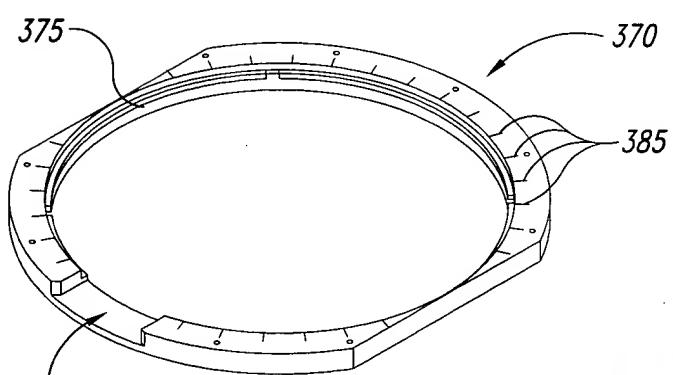
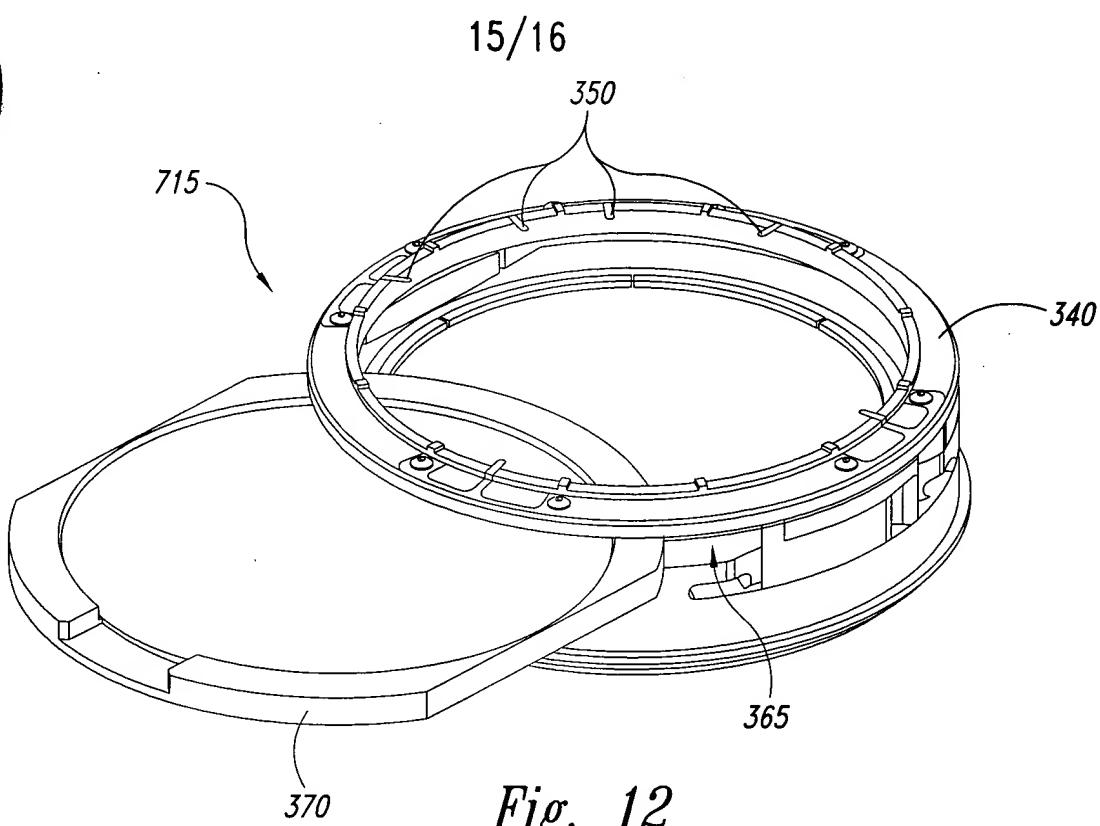


Fig. 13A

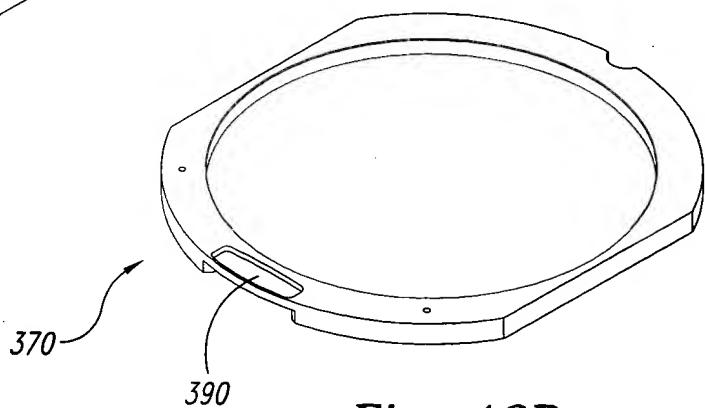
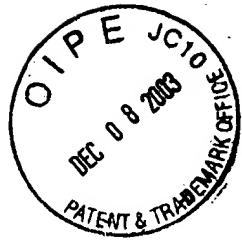


Fig. 13B



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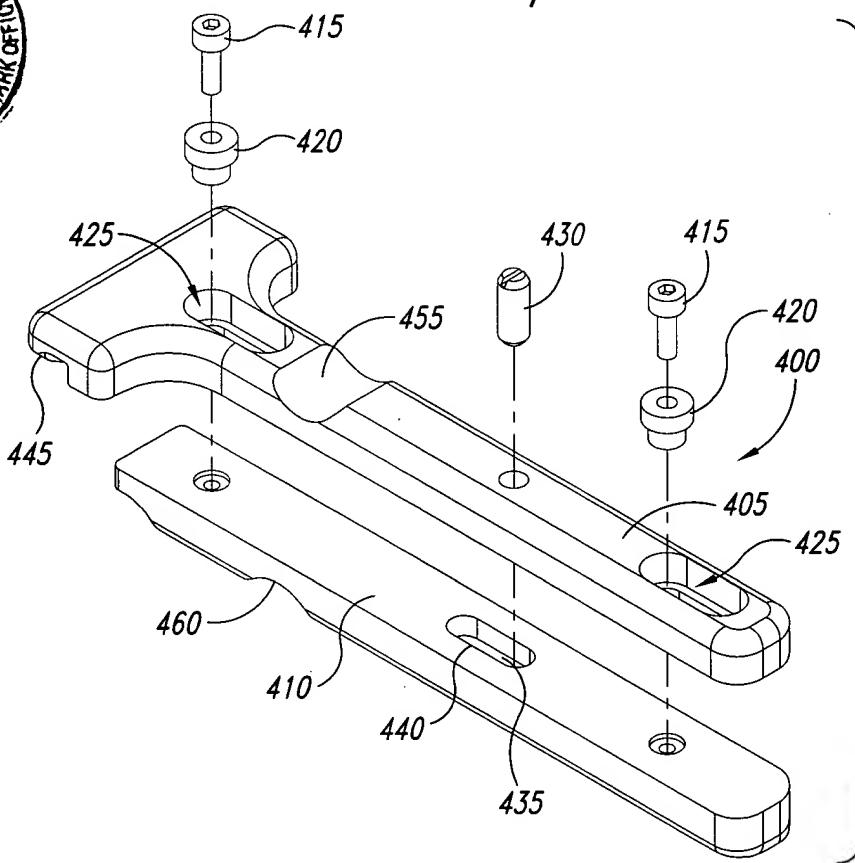


Fig. 14A

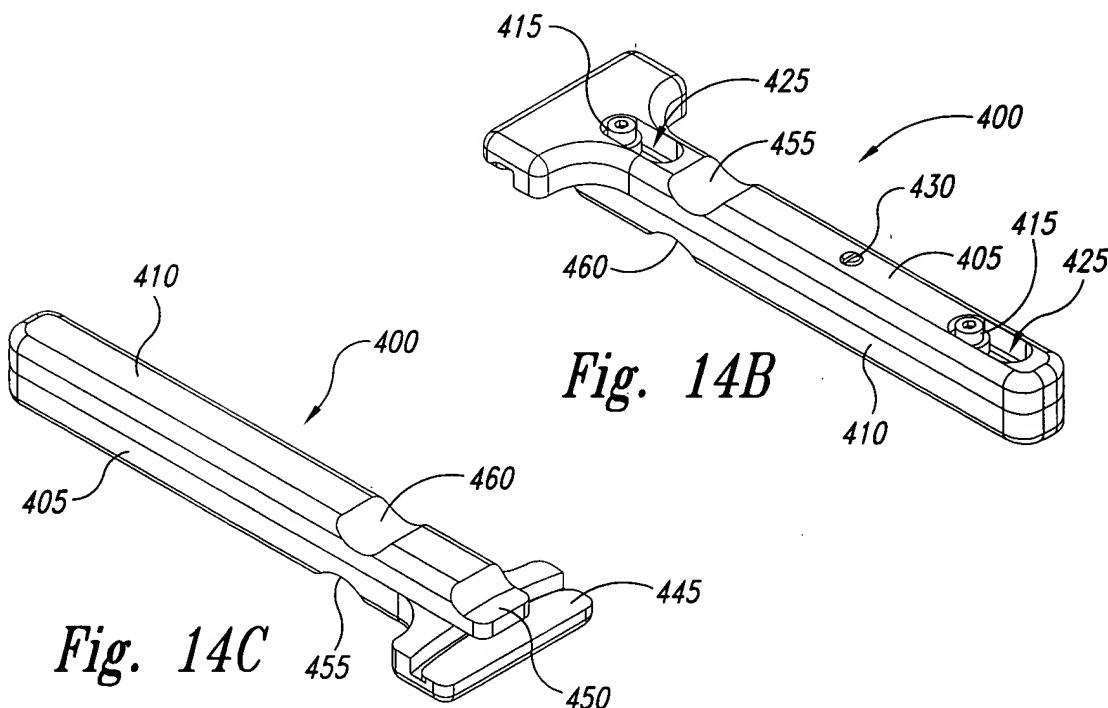


Fig. 14B